

Form PTO-1449 (modified)
INFORMATION DISCLOSURE CITATION

Atty. Docket No.
8398-20

Serial No.

Applicant:
Beaucoup et al.

Filing Date
10 January 2002

Group



U.S. Patent Documents

Examiner Initial	Document Number	Date	Name	Class	Subclass
CPA	5,295,225	03/94	Kane et al.	395	2.35
CPA	5,617,472	04/97	Yoshida et al.	379	390

Foreign Patent Documents

Examiner Initial	Document Number	Date	Country	Name	Class	Subclass
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Non-Patent Documents

Other Documents (including Author, Title, Source, Date, Pertinent Pages)

Examiner

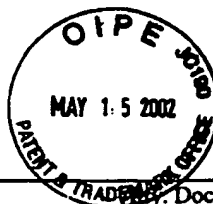
D. Paul Harper

Date Considered

12/22/04

*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Sheet 1 of 1

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10/044,800

Applicant:
Franck Beaucoup and Michael Tetelbaum

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Filing Date
January 10, 2002

Group
2644

Foreign Patent Documents

Examiner Initial	Document Number	Date	Country	Name	Class	Subclass
<i>CPA</i>	2,309,525	11/28/2000	Canada	Mitel Corporation	G10L 11/02	H04L 12/56

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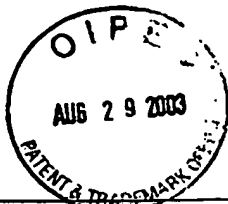
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Franck Beaucoup and Michael Tetelbaum

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2655

Examiner To, Doris Ha

Foreign Patent Documents

Examiner Initial	Document Number	Date	Country	Name	Class/Subclass
<u>CPA</u>	2000305579A	11/02/2000	Japan	Matsushita	G10L11/02; G10L21/02

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